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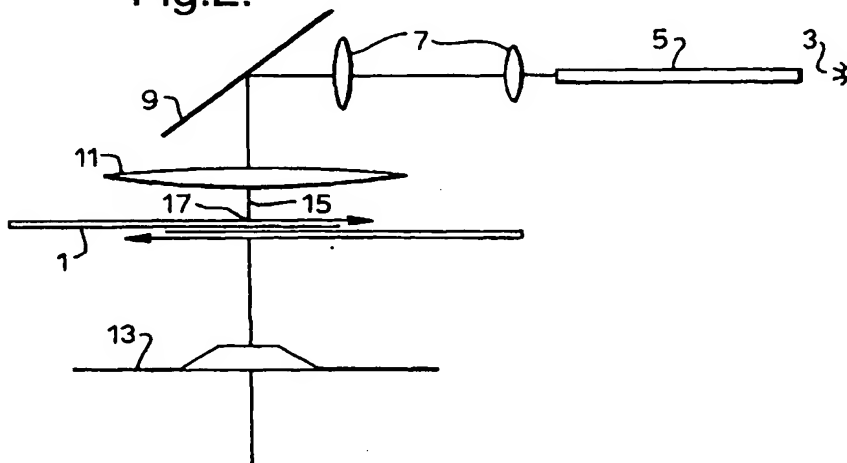
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(54) **Lithography apparatus**

(57) Lithographic projection apparatus and a correction device for lithographic projection apparatus, wherein the lithographic projection apparatus comprises means for projecting a beam of radiation onto a mask (13), characterised in that the correction device com-

prises filter means (1) placed in the path of the beam (15) for varying the spatial intensity of the beam (15) along at least one direction of its cross-section so that the integrated intensity of radiation at mask level (13) is substantially uniform across the entire length of the cross-section.

Fig.2.



EP 0 952 491 A3



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EUROPEAN SEARCH REPORT

Application Number
EP 99 30 2768

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The present search report has been drawn up for all claims			
Place of search THE HAGUE		Date of completion of the search 16 March 2001	Examiner Aguilar, M.
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